



LABORATORY GROWN DIAMOND REPORT

February 9, 2026	
IGI Report Number	LG772686671
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	13.69 x 9.23 x 5.51 mm

GRADING RESULTS

Carat Weight	4.26 CARAT(S)
Color Grade	D
Clarity Grade	VVS 1

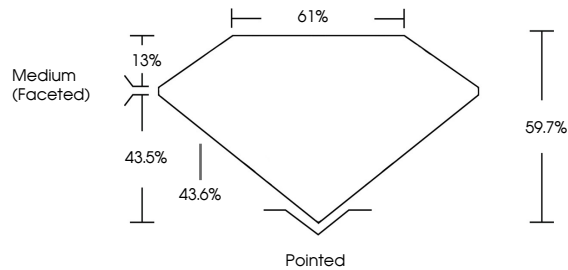
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG772686671

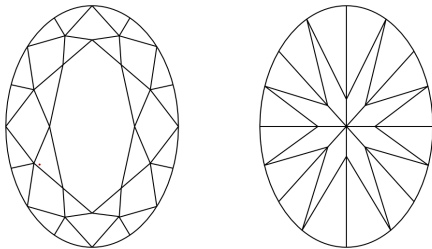
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG772686671
Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

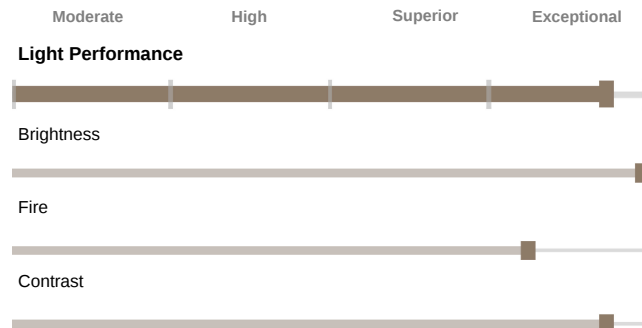
www.igi.org

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Structured Light Environment Representation



COLOR

D E F G H I J Faint Very Light Light

CLARITY

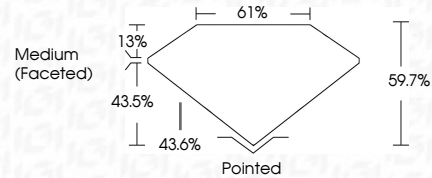
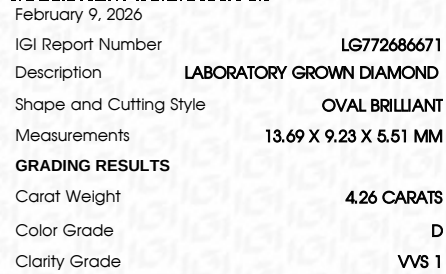
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG1 LG77268667
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



IGI

February 9, 2026	GI Report No LG77266671	4.26 CARATS
Overall Brilliant		D
Color Grade	13.67 X 9.23 X 5.61 MM	VVS 1
Clarity Grade		50.7%
Depth		61%
Table		Medium (Faceted)
Side		
Girdle		
Culet		Pointed
Polish		EXCELLENT
Symmetry		EXCELLENT
Fluorescence		NONE
Inscription(s)		(g) LG77266671

Comments:

This Laboratory Grown Diamond was
 created by Chemical Vapor Deposition
 (CVD) growth process.
 type IIA